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# Cypress Semiconductor Product Qualification Report

**QTP# 063901 VERSION \*B**  
**April 2015**

<b>16 Meg MoBL Devices</b>	
<b>RAM8NLD-1.8V, GSMC (Fab 5)</b>	
<b>CY62165DV18 MoBL® CY62165DV30 MoBL®</b>	<b>16-Mb (1M x 16) Static RAM Die</b>
<b>CY62167DV18 MoBL2™</b>	<b>16M (1024K x 16) Static RAM</b>
<b>CY62167DV20 MoBL2®</b>	<b>16-Mb (1024K x 16) Static RAM</b>
<b>CY62167DV30 MoBL® CY62167DG30 MoBL®</b>	<b>16-Mbit (1M x 16) Static RAM</b>
<b>CY62168DV30 MoBL®</b>	<b>16-Mbit (2M x 8) MoBL® Static RAM</b>
<b>CY62177DV30 MoBL®</b>	<b>32-M (2M X 16) STATIC RAM</b>

**FOR ANY QUESTIONS ON THIS REPORT, PLEASE CONTACT**  
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### PRODUCT QUALIFICATION HISTORY

<b>Qual Report</b>	<b>Description of Qualification Purpose</b>	<b>Date Comp</b>
063901	Qualify 16Meg, MoBL Static RAM CY62167DV* device and family on RAM8NLD-1.8 Technology at GSMC Foundry (Fab 5)	Mar 07
070203	Full Qualification of GSMC AMAT PSG Tool using 16M MoBL SRAM, R8NLD-18 Technology	Mar 07
071203	R8NLD-18 process change (LICM1) at GSMC	May 07
083301	Qualify MM2 minor mask-change for RAM8 16M MoBL family (7G62161DK/7C62161DC/7C62171D) fabricated at Fab5	Nov 08

PRODUCT DESCRIPTION (for qualification)	
Qualification Purpose: Qualify CY62167DV* device and family, RAM8NLD-1.8 Technology at GSCMC (Fab 5)	
Marketing Part #:	CY62165/7DV18, CY62167DV20, CY62167/8DV30, CY62167DG30, CY62177DV30*
Device Description:	1.8V - 3V, Industrial available in 48-ball FBGA and 48-Lead TSOP
Cypress Division:	Cypress Semiconductor Corporation –Memory Product Division (MPD)

TECHNOLOGY/FAB PROCESS DESCRIPTION – RAM8NLD-1.8			
Number of Metal Layers:	2	Metal Composition	Metal 1: 150 Å Ti/250 Å TiN/3500 Å Al Metal 2: 300 Å Ti/200 Å TiN/4500 Å Al/500 Å TiN
Passivation Type and Materials:	1000Å TEOS / 9000Å Si3N4		
Generic Process Technology/Design Rule (μ-drawn):	0.13 μm		
Gate Oxide Material/Thickness (MOS):	32Å		
Name/Location of Die Fab (prime) Facility:	Grace Semiconductor-China		
Die Fab Line ID/Wafer Process ID:	Fab5/RAM8NLD-1.8V		

#### PACKAGE AVAILABILITY

PACKAGE	ASSEMBLY SITE FACILITY
48-Ball FBGA	TAIWAN-G, CML-RA
48-Pin TSOP	TAIWAN-G

**Note:** Package Qualification details upon request

MAJOR PACKAGE INFORMATION USED IN THIS QUALIFICATION		
Package Designation:	BA48	
Package Outline, Type, or Name:	48-Ball Fine Pitch Ball Grid Array (VFBGA)	
Mold Compound Name/Manufacturer:	KE-G2270	
Mold Compound Flammability Rating:	V-O per UL94	
Oxygen Rating Index:	NA	
Substrate Material:	BT Resin	
Lead Finish, Composition / Thickness:	SnPb	SnAgCu
Die Backside Preparation	Backgrind	
Die Separation Method:	100%	
Die Attach Supplier:	Ablestik	
Die Attach Material:	Ablestik 2025D	
Die Attach Method:	Epoxy	
Bond Diagram Designation:	10-06162	10-07075
Wire Bond Method:	Thermosonic	
Wire Material/Size:	Au. 1.0mil	Au. 0.8mil
Thermal Resistance Theta JA °C/W:	28.37 °C/W	
Package Cross Section Yes/No:	N/A	
Assembly Process Flow:	49-41032	001-06964
Name/Location of Assembly (prime) facility:	Taiwan-G	CML-RA
MSL Level	3	
Reflow Profile	220C	260C

ELECTRICAL TEST / FINISH DESCRIPTION	
Test Location:	CML-R

# RELIABILITY TESTS PERFORMED PER SPECIFICATION REQUIREMENT

Stress/Test	Test Condition	Result P/F
High Temperature Operating Life Early Failure Rate	Dynamic Operating Condition, Vcc Max = 2.35V, 125°C	P
High Temperature Operating Life Latent Failure Rate	Dynamic Operating Condition, Vcc Max = 2.35V, 150°C	P
High Temperature Steady State Life Test	Static Operating Condition, Vcc Max = 2.35V, 150°C	P
Low Temperature Operating Life Test	Dynamic Operating Condition, Vcc Max = 2.35V, -30°C	P
High Accelerated Saturation Test (HAST)	JEDEC STD 22-A110: 130C, 3.63V, 85%RH Precondition: JESD22 Moisture Sensitivity MSL 3 192 Hrs, 30C/60%RH, 220 °C Reflow	P
Temperature Cycle	MIL-STD-883C, Method 1010, Condition C, -65 °C to 150 °C Precondition: JESD22 Moisture Sensitivity MSL 3 192 Hrs, 30C/60%RH, 220 °C Reflow	P
Pressure Cooker	JESD22-A102: 121 °C , 100%RH, 15 Psig Precondition: JESD22 Moisture Sensitivity MSL 3 192 Hrs, 30C/60%RH, 220 °C Reflow	P
Acoustic Microscopy	J-STD-020	P
Age Bond	MIL-STD 883, Method 2011	P
Current Density	Meets the Technology Device Level Reliability Specifications	P
Electrostatic Discharge Human Body Model (ESD-HBM)	2,200V JEDEC EIA/JESD22-A114-B	P
Electrostatic Discharge Charge Device Model (ESD-CDM)	500V JESD22-C101	P
High Temperature Storage	JESD22-A103, 150 °C, no bias	P
Static Latch-up	125C, ± 200mA/ ± 140mA JESD78B	P

## RELIABILITY FAILURE RATE SUMMARY

Stress/Test	Device Tested/ Device Hours	# Fails	Activation Energy	Thermal AF <sup>1,3</sup>	Failure Rate <sup>4</sup>
High Temperature Operating Life Early Failure Rate	8,552 Devices	2	N/A	N/A	234 PPM
High Temperature Operating Life <sup>1,2</sup> , Long Term Failure Rate	642,500 DHRs	0	0.7	169	8 FITs

<sup>1</sup> Assuming an ambient temperature of 55°C and a junction temperature rise of 15 °C.

<sup>2</sup> Chi-squared 60% estimations used to calculate the failure rate.

<sup>3</sup> Thermal Acceleration Factor is calculated from the Arrhenius equation

<sup>4</sup> Fit rate calculation based on limited sample size and device hours

$$AF = \exp \left[ \frac{E_A}{k} \left[ \frac{1}{T_2} - \frac{1}{T_1} \right] \right]$$

where:

E<sub>A</sub> =The Activation Energy of the defect mechanism.

K = Boltzmann's constant = 8.62x10<sup>-5</sup> eV/Kelvin.

T<sub>1</sub> is the junction temperature of the device under stress and T<sub>2</sub> is the junction temperature of the device at use conditions.

## Reliability Test Data

**QTP #: 063901**

<b>Device</b>	<b>Fab Lot #</b>	<b>Assy Lot #</b>	<b>Assy Loc</b>	<b>Duration</b>	<b>Samp</b>	<b>Rej</b>	<b>Failure Mechanism</b>
<b>STRESS: ACOUSTIC-MSL3</b>							
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	COMP	15	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	COMP	15	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	COMP	15	0	
<b>STRESS: AGE BOND</b>							
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	COMP	10	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	COMP	10	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	COMP	10	0	
<b>STRESS: ESD-CHARGE DEVICE MODEL, 500V</b>							
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	COMP	9	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	COMP	9	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	COMP	9	0	
<b>STRESS: ESD-HUMAN BODY CIRCUIT PER JEDEC EIA/JESD22-A114-B, 2,200V</b>							
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	COMP	8	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	COMP	8	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	COMP	8	0	
<b>STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-EARLY FAILURE RATE, 125C, 2.35V, Vcc Max</b>							
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	96	1540	1	LICON-Poly Narrow Spacing <sup>1</sup>
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	96	961	0	
CY62167DV30LL (7G62162DK)	9650743	610675324	TAI/WN-G	96	257	0	
CY62167DV30LL (7G62162DK)	9650743	610703289	TAI/WN-G	96	252	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	96	996	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	96	812	1	Particle Defect <sup>2</sup>

1. CAR#200710021.1- process fix to increase LICON-Poly space, QTP# 071203 passed EFR and objective spec audit.

2. CAR# 200710033.1 – test program improvement to screen out random particle defect.



## Reliability Test Data

QTP #: 063901

Device	Fab Lot #	Assy Lot #	Ass Loc	Duration	Samp	Rej	Failure Mechanism
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### STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-LATENT FAILURE RATE, 150C, 2.35V, Vcc Max

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	80	500	0	
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	500	500	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	80	495	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	500	491	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	500	150	0	

### STRESS: HIGH TEMP STEADY STATE LIFE TEST, 150C, 2.35V, Vcc Max

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	80	80	0	
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	168	80	0	

### STRESS: LOW TEMPERATURE OPERATING LIFE TEST, -30C, 2.35V, Vcc Max

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	500	45	0	
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### STRESS: HIGH TEMPERATURE STORAGE, 150C, no bias

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	500	50	0	
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	1000	50	0	

### STRESS: HI-ACCEL SATURATION TEST, 130C, 85%RH, 3.6V, PRE COND 192 HR 30C/60%RH, MSL3

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	128	44	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	128	44	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	128	45	0	

### STRESS: PRESSURE COOKER TEST, 121C, 100%RH, 15 Psig, PRE COND 192 HR 30C/60%RH, MSL3

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	168	44	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	168	45	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	288	45	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	168	48	0	

## Reliability Test Data

QTP #: 063901

Device	Fab Lot #	Assy Lot #	Ass Loc	Duration	Samp	Rej	Failure Mechanism
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**STRESS: TC COND. C -65C TO 150C, PRE COND 192 HRS 30C/60%RH, MSL3**

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	300	43	0	
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	500	43	0	
CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	1000	43	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	300	43	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	500	43	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	1000	43	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	300	44	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	500	44	0	

**STRESS: STATIC LATCH-UP TESTING, 125C, 6.5V, ±200mA**

CY62167DV30LL (7G62162DK)	9649742	610673573	TAI/WN-G	COMP	3	0	
CY62167DV30LL (7G62162DK)	9650743	610675172	TAI/WN-G	COMP	3	0	
CY62167DV30LL (7G62162DK)	9703749	610704375	TAI/WN-G	COMP	3	0	

## Reliability Test Data

**QTP #: 070203**

<b>Device</b>	<b>Fab Lot #</b>	<b>Assy Lot #</b>	<b>Ass Loc</b>	<b>Duration</b>	<b>Samp</b>	<b>Rej</b>	<b>Failure Mechanism</b>
<b>STRESS: ESD-CHARGE DEVICE MODEL, 500V</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	COMP	9	0	
CY62167DV30LL (7G62162DK)	9705754	610706804	TAIWN-G	COMP	9	0	
<b>STRESS: ESD-HUMAN BODY CIRCUIT PER JEDEC EIA/JESD22-A114-B, 2,200V</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	COMP	8	0	
CY62167DV30LL (7G62162DK)	9705754	610706804	TAIWN-G	COMP	8	0	
<b>STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-EARLY FAILURE RATE, 125C, 2.35V, Vcc Max</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	96	1504	0	
CY62167DV30LL (7G62162DK)	9705754	610706804	TAIWN-G	96	1499	0	
<b>STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-LATENT FAILURE RATE, 150C, 2.35V, Vcc Max</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	500	144	0	
<b>STRESS: HI-ACCEL SATURATION TEST, 130C, 85%RH, 1.98V, PRE COND 192 HR 30C/60%RH, MSL3</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	128	44	0	
CY62167DV30LL (7G62162DK)	99705754	610706804	TAIWN-G	128	45	0	
<b>STRESS: PRESSURE COOKER TEST, 121C, 100%RH, 15 Psig, PRE COND 192 HR 30C/60%RH, MSL3</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	168	79	0	
CY62167DV30LL (7G62162DK)	9705754	610706804	TAIWN-G	168	77	0	
<b>STRESS: TC COND. C -65C TO 150C, PRE COND 192 HRS 30C/60%RH, MSL3</b>							
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	500	78	0	
CY62167DV30LL (7G62162DK)	9703749	610704374	TAIWN-G	1000	77	0	
CY62167DV30LL (7G62162DK)	9705754	610706804	TAIWN-G	500	76	0	
CY62167DV30LL (7G62162DK)	9705754	610706804	TAIWN-G	1000	68	0	



## Reliability Test Data

**QTP #:** 071203

<b>Device</b>	<b>Fab Lot #</b>	<b>Assy Lot #</b>	<b>Ass Loc</b>	<b>Duration</b>	<b>Samp</b>	<b>Rej</b>	<b>Failure Mechanism</b>
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**STRESS:** HIGH TEMP DYNAMIC OPERATING LIFE-EARLY FAILURE RATE, 125C, 2.35V, Vcc Max

CY62167DV30LL (7G62162DK)	9709761	610714797	TAIWAN-G	96	731	0	
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## Reliability Test Data

QTP #: 083301

Device	Fab Lot #	Assy Lot #	Ass Loc	Duration	Samp	Rej	Failure Mechanism
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**STRESS: E-TEST YIELD**

CY62177DV30 (7C62171D)	4829459	N/A	N/A	COMPARABLE			
CY62167DV30 (7C62161D)	4833178	N/A	N/A	COMPARABLE			
CY62167DV30 (7G62161D)	4835716	N/A	N/A	COMPARABLE			

**STRESS: SORT YIELD**

CY62177DV30 (7C62171D)	4829459	N/A	N/A	COMPARABLE			
CY62167DV30 (7C62161D)	4833178	N/A	N/A	COMPARABLE			
CY62167DV30 (7G62161D)	4835716	N/A	N/A	COMPARABLE			

## Document History Page

Document Title: QTP 063901: 16 MEG MOBL DEVICES (CY62167D AND FAMILY) RAM8NLD-1.8V, FAB 5  
Document Number: 001-87387

Rev.	ECN No.	Orig. of Change	Description of Change
**	3986168	ILZ	Initial Spec Release Documented & converted Memo # HGA-647 into qualification report spec format Removed Version 4.0 in the title page. Removed Cypress reference specs in the reliability tests performed table. Technology/Fab Process Description – Page 3 Corrected Generic Process Technology/Design Rule ( $\mu$ -drawn) data from 0.15 $\mu$ m to 0.13 $\mu$ m
*A	4362868	HSTO	Align qualification report based on the new template in the front page. Update Cypress division on page 3 from Memory Image Division (MID) -> Memory Product Division (MPD)
*B	4749323	HSTO	Update reference for Reliability Director

Distribution: WEB

Posting: None